

Notice of References Cited	Application/Control No. 09/995,421		Applicant(s)/Patent Under Reexamination CHUNG ET AL.	
	Examiner Kibrom K. Gebresilassie		Art Unit 2128	Page 1 of 1

U.S. PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
	A	US-5,070,469 A	12-1991	Kunikiyo et al.	716/20
	B	US-5,717,294 A	02-1998	Sakai et al.	315/111.41
	C	US-5,819,073 A	10-1998	Nakamura, Mitsutoshi	716/20
	D	US-5,907,820 A	05-1999	Pan, Shaoher X	702/155
	E	US-6,014,943 A	01-2000	Arami et al.	118/723E
	F	US-6,199,029 B1	03-2001	Ohta, Toshiyuki	703/1
	G	US-2002/0101167 A1	08-2002	Shan et al.	315/111.11
	H	US-6,716,302 B2	04-2004	Carducci et al.	156/345.47
	I	US-6,797,639 B2	09-2004	Carducci et al.	438/710
	J	US-6,805,770 B1	10-2004	Oster, Eugene L.	156/345.42
	K	US-			
	L	US-			
	M	US-			

FOREIGN PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Country	Name	Classification
	N					
	O					
	P					
	Q					
	R					
	S					
	T					

NON-PATENT DOCUMENTS

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
	U	Dimitris P. Lymberopoulos and Demetre J. Economou, Two-dimensional Self-Consistent Radio Frequency Plasma Simulations Relevant to the Gaseous Electronics Conference RF Reference Cell, July-August 1995, Journal of Research of the National Institute, Vol. 4.
	V	
	W	
	X	

*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)
Dates in MM-YYYY format are publication dates. Classifications may be US or foreign.